

**UTILITY
PATENT APPLICATION
TRANSMITTAL**

(Only for new nonprovisional applications under 37 CFR 1.53(b))

JC860 U.S. PTO

Attorney Docket No.	206342US2
First Inventor or Application Identifier	Toshifumi NAKAYAMA, et al.
Title	WORKTABLE DEVICE AND PLASMA PROCESSING APPARATUS FOR SEMICONDUCTOR PROCESS

Assignee Name:

Assignee Address:

U.S. PTO

09/840

IC986

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04/24/01

04/24/01 APPLICATION ELEMENTS

See MPEP chapter 600 concerning utility patent application contents

1. Fee Transmittal Form (e.g. PTO/SB/17)
(Submit an original and a duplicate for fee processing)
2. Specification Total Sheets **17**
3. Drawing(s) (35 U.S.C. 113) Total Sheets **4**
Formals
4. Oath or Declaration Total Pages
 a. Newly executed (original or copy)
 b. Copy from a prior application (37 C.F.R. §1.63(d))
(for continuation / divisional w/ box 17 completed)
 i. DELETION OF INVENTOR(S)
Signed statement attached deleting inventor(s) named in
the prior application. see 37 C.F.R. §1.63(d)(2) and
1.33(b).
5. CD-ROM or CD-R in duplicate, large table or Computer
Program (*Appendix*)
6. Nucleotide and/or Amino Acid Sequence Submission
(*if applicable, all necessary*)
 a. Computer Readable Form (CRF)
 b. Specification or Sequence Listing on:
 i. CD-ROM or CD-R (2 copies); or
 ii. Paper
 c. Statements verifying identity of above copies

ADDRESS TO: Assistant Commissioner for Patents
Box Patent Application
Washington, DC 20231

ACCOMPANYING APPLICATION PARTS

7. Assignment Papers (cover sheet & document(s))
 8. Application Data Sheet. See 37 CFR 1.76
 9. 37 C.F.R. §3.73(b) Statement Power of Attorney
 10. English Translation Document (*if applicable*)
 11. Information Disclosure Statement (IDS)/PTO-1449 Copies of IDS
Citations (1)
 12. Preliminary Amendment
 13. White Advance Serial No. Postcard
 14. Certified Copy of Priority Document(s)
(*if foreign priority is claimed*)
 15. Applicant claims small entity status.
See 37 CFR 1.27
 16. Other: Notice of Priority, List of Inventors' Names
and Addresses, Statement Re Filing in
Foreign Language

17. If a CONTINUING APPLICATION, check appropriate box, and supply the requisite information below:

Continuation Divisional Continuation-in-part (CIP) of prior application no.:

Group Art Unit:

Prior application information: Examiner:

For CONTINUATION OR DIVISIONAL APPS only: The entire disclosure of the prior application, from which an oath or declaration is supplied under Box 4b, is considered a part of the accompanying continuation or divisional application and is hereby incorporated by reference. The incorporation can only be relied upon when a portion has been inadvertently omitted from the submitted application parts.

18. Amend the specification by inserting before the first line the sentence:

- This application is a Continuation Division Continuation-in-part (CIP)
of application Serial No. Filed on
- Which was published in English
- Which was not published in English
- This application claims priority of provisional application Serial No. Filed

19. CORRESPONDENCE ADDRESS



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Name:	Marvin J. Spivak	Registration No.:	24,913
Signature:		Date:	4/24/01
Name:	C. Irvin McClelland	Registration No.:	

Registration Number 21,124

Docket No. 206342US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Toshifumi NAGAIWA, et al.

SERIAL NO. NEW APPLICATION

FILING DATE: HEREWITH

FOR: WORKTABLE DEVICE AND PLASMA PROCESSING APPARATUS FOR SEMICONDUCTOR PROCESS

STATEMENT RE FILING IN FOREIGN LANGUAGE

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

It is hereby stated that the subject application is being filed in a foreign language, in accordance with the provisions of 37 CFR 1.52(d).

An accurate English translation, and a suitable amendment placing the application and claims thereof into proper U.S. format if needed, will be filed in due course.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



Marvin J. Spivak
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C. Irvin McClelland
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Docket No. 206342US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Toshifumi NAGAIWA, et al.

SERIAL NO: New Application

FILING DATE: Herewith

FOR: WORKTABLE DEVICE AND PLASMA PROCESSING APPARATUS FOR SEMICONDUCTOR PROCESS

FEES TRANSMITTAL

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS
TOTAL CLAIMS	20 - 20 =	0	x \$18 =	\$0.00
INDEPENDENT CLAIMS	2 - 3 =	0	x \$80 =	\$0.00
<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS (If applicable)			+ \$270 =	\$0.00
<input checked="" type="checkbox"/> LATE FILING OF DECLARATION			+ \$130 =	\$130.00
			BASIC FEE	\$710.00
			TOTAL OF ABOVE CALCULATIONS	\$840.00
<input type="checkbox"/> REDUCTION BY 50% FOR FILING BY SMALL ENTITY				\$0.00
<input checked="" type="checkbox"/> FILING IN NON-ENGLISH LANGUAGE			+ \$130 =	\$130.00
<input type="checkbox"/> RECORDATION OF ASSIGNMENT			+ \$40 =	\$0.00
			TOTAL	\$970.00

- Please charge Deposit Account No. 15-0030 in the amount of A duplicate copy of this sheet is enclosed.
- A check in the amount of \$970.00 to cover the filing fee is enclosed.
- The Commissioner is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030.
A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Date: 4/24/01


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